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Priority  
4-1992

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10869 U.S. PRO  
10/058319  
01/30/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: C. MIYAZAKI et al.  
Serial No.: (new continuation application under  
37 CFR 1.53[b] of application  
Serial No. 09/768,451)  
Filed: January 30, 2002  
For: SEMICONDUCTOR DEVICE AND MANUFACTURING  
METHOD THEREOF  
Group: 2811  
Examiner: THAI, L.  
CLAIM FOR PRIORITY  
January 30, 2002

Assistant Commissioner for Patents  
Washington, D. C. 20231

Sir:  
Pursuant to 35 U.S.C. §119 and 37 CFR §1.55, Applicants  
hereby claim the right of priority based on the following  
foreign application filed in Japan:  
**Application No. 08-066637, filed on March 22, 1996**  
A certified copy of this foreign application was filed  
on June 27, 1997 in prior, original U. S. application Serial  
No. 08/822,933, filed on March 21, 1997.

Respectfully submitted,  
ANTONELLI, TERRY, STOUT & KRAUS, LLP

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